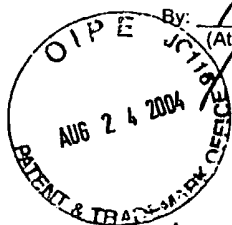


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By: [Signature]
(Attorney Signature and Reg. No.) 50,591

Patent
Attorney's Docket No. 10015155-1

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of)	Mail Stop AF
Laurie S. Mittelstadt et al.)	Group Art Unit: 1745
Application No.: 10/091,485)	Examiner: Yuan, Dah Wei D
Filed: March 7, 2002)	Confirmation No.: 9468
For: ION EXCHANGE SYSTEM)	
STRUCTURE WITH A)	
MICROTEXTURED SURFACE,)	
METHOD OF MANUFACTURE,)	
AND METHOD OF USE THEREOF)	

AMENDMENT PURSUANT TO 37 C.F.R. §1.116

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Official Action mailed May 28, 2004, please amend the above-identified patent application as follows: